

PTO/SB-08B (07-05)  
Approved for use through 07/31/2006

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

**Complete if Known**

Application Number	10/560,516
Filing Date	December 13, 2005
First Named Inventor	Jorg Muller
Art Unit	1645
Examiner Name	Not yet assigned
Attorney Docket Number	P&P-102

Sheet	1	of	2
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**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article, (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/J.H./	R1	FEUSTEL, A. et al., "A Micro Mass Spectrometer," <i>Sensor Kongressband</i> , 1995, pages 465-470.	
/J.H./	R2	FEUSTEL, A. et al., "A Microsystem Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 1994, pages 299-304.	
/J.H./	R3	GREVESMÜHL, B. "Miniaturisierte Gaschromatographie-Module verbessern Prozesse in der Chemie," <i>P&amp;A Kompendium</i> , 2005/2006, pages 164-165	
/J.H./	R4	LEHMANN, U., "Analysis in miniature," <i>Vacuum Solutions</i> , November/December 1998, pages 13-15.	
/J.H./	R5	LEHMANN, U., "Autarky Gas Chromatographic System Realized in MEMS Technology on a Credit Card-Sized Board," <i>Abstracts Pittcon</i> , 2005, 180-9.	
/J.H./	R6	LEHMANN, U., "Kleinste Flüsse messen," <i>Journal Forschung und Entwicklung</i> , Heft 6, 2002, Vol. 44, pages 32-35.	
/J.H./	R7	LEHMANN, U. et al., "A micro gas chromatograph based on a plasma polymerized siliconorganic stationary phase," <i>Sensor Kongressband II</i> , 1997, pages 151-153.	
/J.H./	R8	LEHMANN, U. et al., "Micro machined analytical gas chromatograph with a plasma polymerised stationary phase," <i>Sensor Proceedings II</i> , 2001, pages 487-492.	
/J.H./	R9	LEHMANN, U. et al., "Micro machined gas chromatograph based on a plasma polymerised stationary phase," <i>Micro Total Analysis Systems</i> , 2000, pages 167-170.	
/J.H./	R10	LEHMANN, U. et al., "Mikrogaschromatograph basierend auf einer plasmapolymerisierten siliziumorganischen stationären Phase," <i>Jahrg.</i> , 1999, Vol. 53, No. 7, pages 47-49	

Examiner Signature	/Jonathan Hurst/	Date Considered	03/26/2009
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\*EXAMINER Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 2 of 2

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/J.H./	R11	LEHMANN, U. <i>et al.</i> , "A Miniaturised Gas Chromatographic Module on a Credit Card Sized Motherboard," <i>Sensor Proceedings</i> , 2003, pages 157-161.	
/J.H./	R12	LEHMANN, U. <i>et al.</i> , "A miniaturized gas chromatograph for autonomous and longtime measurements," <i>Sensor Proceedings I</i> , 1999, pages 155-158.	
/J.H./	R13	LEHMANN, U., "A Packed Column Realized on a 1 cm <sup>2</sup> Sized Silicon Glass Chip for Permanent Gas Separation," <i>Abstracts Pittcon</i> , 2005, 1910-5P.	
/J.H./	R14	LEHMANN, U., "World's Smallest, Self-Sufficient Gas Chromatography Module from SLS Micro Technology," <i>Abstracts Pittcon</i> , 2004, 1100-100.	
/J.H./	R15	"Small is Beautiful," <i>The Column</i> , July 2005, pages 22-23.	
/J.H./	R16	PETZOLD, G. <i>et al.</i> , "A Micro Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 2001, pages 224-226.	
/J.H./	R17	SIEBERT, P. <i>et al.</i> , "Processing of Complex Microsystems: A Micro Mass Spectrometer," <i>Symposium on Design, Test, and Microfabrication of MEMS and MOEMS</i> , March-April 1999, Vol. 3680, pages 562-571, Paris, France.	
/J.H./	R18	SIEBERT, P. <i>et al.</i> , "Surface microstructure/miniature mass spectrometer: processing and applications," <i>Appl. Phys. A</i> , 1998, Vol. 67, pages 155-160.	
	R19		
	R20		

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